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THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: SUGIYAMA et al.

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Serial No.: 10/814,179

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Title: EQUIPMENT AND METHOD FOR
MANUFACTURING SILICON CARBIDE
SINGLE CRYSTAL

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop Amendment
Randolph Building
401 Dulany St.
Alexandria, VA 22314

Date: 26 September 2006

RESPONSE UNDER 37 CFR 1.111

Sir:

In response to the office action mailed 27 June 2006, please enter the following remarks:

Remarks begin on page 2 of this paper.